



U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT**

Docket Number:
10191/3399

Application Number
10/691,108

Filing Date
October 22, 2003

Examiner
To Be Assigned

Art Unit
1763

Invention Title
DEVICE AND METHOD FOR ANISOTROPIC
PLASMA ETCHING OF A SUBSTRATE,
PARTICULARLY A SILICON ELEMENT

Inventor(s)
Klaus BREITSCHWERDT et al.

Commissioner for Patents
P.O. Box 1450
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

Date: 5-26-04

Signature: Bernadette DiSarna

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicant hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. The filing of this Information Disclosure Statement and the enclosed PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).
2. A copy of each patent, publication or other information listed on the modified PTO Form No. 1449 is enclosed, unless indicated otherwise.
3. It is believed that no fees are due in connection with this Information Disclosure Statement. However, should any fees be due, the Commissioner is authorized to charge deposit account number 11-0600 for such fees. A copy of this communication is enclosed for charging purposes.

Dated: 5/26/04

By: Richard L. Mayer (Reg. No. 22,490)

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BY APPLICANT
PTO-1449**

DOCKET NO.
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APPLICANT
Klaus BREITSCHWERDT et al.

FILING DATE
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GROUP
1763

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE*
	6,303,512*	October 16, 2001	Laermer et al.			
	5,501,893*	March 26, 1996	Laermer et al.			
	6,217,704*	April 17, 2001	Kitagawa			

*Copy of patent not enclosed since application was filed after June 30, 2003.

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS

EXAMINER INITIAL		AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	